

APPLICATION DATA SHEET

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Application Information: Title: METHOD AND STRUCTURE FOR PROTECTING NROM DEVICES FROM INDUCED CHARGE DAMAGE DURING DEVICE FABRICATION
 Classification: Class: Subclass:
 Tech Center:
 Drawing Sheets: 2 Drawing to be Published:
 Docket No: H1369
 Type: Utility
 Secrecy: None

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Domestic Priority:

Application:	Continuity Type:	Parent Application:	Parent Filing Date:
None			

Foreign Priority Information

Country:	Application Number:	Filing Date:	Priority Claimed:
None			

Assignee: Advanced Micro Devices, Inc.
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